



94198

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: MAEDA et al.

Serial No.: 10/533,147

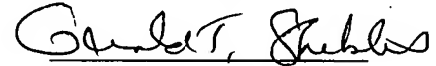
Filed: April 27, 2005

For: METHOD FOR PRODUCING SILICON WAFER

) Art Unit:

) Confirmation No.:

) I hereby certify that this
) correspondence is being
) deposited with the United Postal
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Box 1450 / Alexandria, Virginia
22313-1450, on July 19, 2007.



Gerald T. Shekleton Reg.
No. 27,466

Response to Office Action dated March 19, 2007

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

The Office Action of March 19, 2007, has been carefully reviewed and the following amendments and remarks are made in response thereto.